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To: **Corrected Filing Receipt Requests - Fax**
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From: Sue Short/Charles A. Brill
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Ehmke *et al.*

Docket: TI-34210

Application No.: 10/747,862

Examiner: TBD

Filed: 12/29/2003

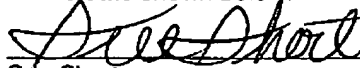
Art Unit: 2815

Conf. No.: 2777

For: Method for Fabricating a Lid for a Wafer Level Packaged Optical MEMS Device

CERTIFICATION OF FACSIMILE TRANSMISSION

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Sue Short

June 29, 2004
Date

FACSIMILE COVER SHEET

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<input type="checkbox"/> CONTINUATION APP'N (# Pages)	<input checked="" type="checkbox"/> Request to Correct Filing Receipt, copy of marked-up Filing Receipt, copy of Declaration and Power of Attorney
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S): Ehmke <i>et al.</i>	
RECEIPT DATE & SERIAL NO.: Application No.: 10/747,862	
TITLE OF INVENTION: Method for Fabricating a Lid for a Wafer Level Packaged Optical MEMS Device	
TI FILE NO.: TI-34210	DEPOSIT ACCT. NO.: 20-0668
FAXED: 6/29/04 DUE: ATTY/SEC'Y: CAB:ss	

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Texas Instruments Incorporated
PO Box 655474, M/S 3999
Dallas, TX 75265

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	Ehmke <i>et al.</i>	Docket No.:	TI-34210
Appln. No:	10/747,862	Art Unit:	2815
Filed:	12/29/2003	Examiner:	TBD
For:	Method for Fabricating a Lid for a Wafer Level Packaged Optical MEMS Device	Conf. No.:	2777

REQUEST TO CORRECT FILING RECEIPT

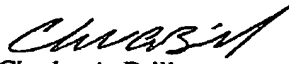
Office of Initial Patent Examination
Filing Receipt Corrections
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

Attached is a copy of the official Filing Receipt received from the United States Patent and Trademark Office in the above-identified application with changes noted thereon. Applicants respectfully request that the filing receipt for S/N 10/747,862 be corrected to reflect inventor Lopes' correct name of Vincent C. Lopes as listed in the attached Declaration and Power of Attorney sent via Facsimile on 5/5/2004 in Response to the Notice to File Missing Parts of Nonprovisional Application. The Filing Receipt should also reflect the title "Method for fabricating a lid for a wafer level packaged optical MEMS device" as shown by the enclosed Declaration and Power of Attorney, "device" is not plural as reflected on the Filing Receipt.

Applicants request that a Corrected Filing Receipt be issued reflecting the correct inventor's name and title change. Applicants believe that no fees are required in connection with this filing. However, to the extent that fees are required, the Commissioner is authorized to charge those fees, or credit any overpayment to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Respectfully submitted,


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CAB



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/747,862	12/29/2003	2815	0.00	TI-34210	4	25	2

CONFIRMATION NO. 2777

23494

TEXAS INSTRUMENTS INCORPORATED
P O BOX 655474, M/S 3999
DALLAS, TX 75265

FILING RECEIPT



OC000000012341949

Date Mailed: 04/13/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

John C. Ehmke, Garland, TX;

Vincent C. Lopes, Lucas, TX;

John Paul Harris, Whitewright, TX;

Vincent C. Lopes, Lucas, TX;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 04/13/2004

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Method for fabricating a lid for a wafer level packaged optical MEMS devices

Preliminary Class

RECEIVED

APR 16 2004

PATENT DEPT

KV

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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